



IMEC100.001DV1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Baklanov, et al.
Appl. No. : 09/844,959
Filed : April 27, 2001
For : FLUORINATED HARD MASK
FOR MICROPATTERNING OF
POLYMERS
Examiner : Trinh, H. B.
Group Art Unit : 2814

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

August 26, 2003

(Date)

Rose Thiessen, Reg. No. 40,202

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AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed June 4, 2003, Applicants respectfully request that the Examiner enter the following amendments and consider the following remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.